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Design, Technology and Test Protocols for Microsystem High Frequency Devices

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Message from the Guest Editors

In this Special Issue, research papers, short communications, and review article contributions are welcome in describing the state-of-the-art for design, technology, and test protocols for high frequency microsystems.

Keywords

- MEMS
- NFMS
- microwaves
- millimeter waves













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Message from the Editor-in-Chief

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